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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Donald L. Yates

Serial No.: 10/027,951

Filed: December 19, 2001

For: METHOD OF REDUCING WATER SPOTTING AND OXIDE GROWTH ON A SEMICONDUCTOR STRUCTURE

Examiner: Unknown

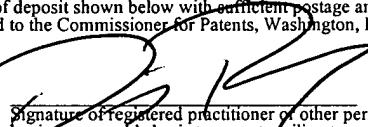
Group Art Unit: 1746

Attorney Docket No.: 3375.6US (95-0999.5)

CERTIFICATE OF MAILING

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Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.

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